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OCT 29 2004 CO

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant

Martin Richardson

Serial No.

10/795,814

Filed

03/08/2004

TC/A.U.

2878

Examiner

Thomas D. Courtney

Docket No.

UCF-306DIV

Customer No.

23717

For

EUV, XUV, AND X-RAY WAVELENGTH SOURCES

CREATED FROM LASER PLASMA PRODUCED FROM

LIOUID METAL SOLUTIONS, AND NANO-SIZE PARTICLES

IN SOLUTION

Commissioner of Patents and Trademarks

P.O. Box 1450

Alexandria, VA 22313-1450

MAILED: 10/25/04

Honorable Commissioner:

I enclose the following papers:

1. Amendment Response and Arguments

Please enter the above correspondence.

Respectfully submitted,

Brian S. Steinberger

Attorney at Law

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CERTIFICATE OF MAILING (37 CFR 1.8a)

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below as First Class Mail, in an envelope addressed to the: Commissioner of Patents and Trademarks, P.O. Box 1450 Alexandria, VA 22313-1450.

10/25/04 Date

Brian S. Steinberger (Name of Person Mailing Attached Papers)

(Signature of Person Mailing Attached Papers)



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Honorable Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the office action mailed July 23, 2004, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims, which begins on page 2 of this paper.

Remarks/Arguments begin on page 8 of this paper.